

01-22-2

A

Docket No. AMAT 005027
422.04.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Commissioner of Patents and Trademarks
Washington, D.C. 20231

Re: Inventor(s): Ling Chen and Wei Cao
Title: METHOD FOR GROWING THIN FILMS BY CATALYTIC ENHANCEMENT

J1040 U.S. PRO
10/052049
01/16/02

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 12 pages.
- ☐ Drawings totaling pages, Formal ☒ Informal.
- ☒ Unsigned Declaration and Power of Attorney.
- ☐ Assignment of the invention to Applied Materials, Inc.
- ☐ Assignment Recordation Cover Sheet
- ☐ Information Disclosure Statement (37 CFR 1.98)

| FEE CALCULATION | | | | | |
|--------------------|--------------|-------------------------|--------------|----------|----------|
| Fee Items | Claims Filed | Included With Basic Fee | Extra Claims | Fee Rate | Total |
| Total Claims | 20-- | -20= | 0 | X\$18.00 | \$000.00 |
| Independent Claims | 3-- | -3= | 0 | X\$84.00 | \$000.00 |
| Basic Filing Fee | | | | \$740.00 | \$740.00 |
| TOTAL FEES | | | | | \$740.00 |

- ☐ The Commissioner is hereby authorized to charge \$000000000 to Deposit Account No. 04-0822.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-0822. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:

PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Patent Application, Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Express Mail Receipt No. EL902870605US

Date of Deposit January 16, 2002

Signature Donald R. McKenna

Respectfully submitted,

Donald R. McKenna

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Registration No. 44,922